A Raman study of Au/Te/Au/GaAs (100) ohmic contacts

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Ohmic contacts produced by high-energy pulsed laser beam alloying Au/Te/Au/n-GaAs are investigated by micro Raman spectroscopy. The results are compared to those from furnace annealed ohmic contacts. For the furnace as well as for the laser annealed ohmic contacts, no evidence for a doping of the contact region is found in the Raman spectra. The presence of a highly disordered GaAs surface layer is observed for both types of contacts. In addition, after furnace processing a Ga₅Te₅ layer is formed. These results are consistent with earlier Mössbauer studies. For the laser alloyed samples the results strengthen the role of a defective/disordered interface structure where conduction might occur by a resonant tunneling process involving localized gap states.

I. INTRODUCTION

The study of ohmic contacts to n-GaAs has been a main subject of research activities for many years. The most commonly used contact metallization is (Ni/)Au/Ge which has become an industrial standard. Nowadays nonalloyed contacts like Pd/Ge (Ref. 3) become more important for the semiconductor technology. New developments which should also be mentioned are Pd/In (Ref. 4) and In/W (Ref. 5) contacts. However, the mechanism responsible for the ohmic behavior of especially the Ge based contacts is still a point of discussion.

The most popular model to explain the ohmic behavior for these contacts involves the formation of a highly doped GaAs surface layer. For good ohmic characteristics a doping level of about 2 x 10¹⁹ cm⁻³ and a thickness of the doped layer of about 15 nm is required which allows quantum mechanical tunneling to occur due to the narrowing of the metal/semiconductor potential barrier. The second type of models requires the formation of a graded amorphous or crystalline heterojunction. In the model of a graded crystalline heterojunction the abrupt metal/GaAs transition is replaced by the formation of an intermediate mixed semiconductor layer. The composition of this layer varies in such a way that the potential barrier is reduced. The required grading width depends on the doping level of the substrate and of the overlayer. For an amorphous heterojunction the current transport can be due to a phonon assisted hopping or alternatively by a multistep tunneling process between localized gap states at the metal/semiconductor interface.

To extend the study of the nature of n-GaAs ohmic contacts, a Au/Te metallization scheme, which—after furnace or laser alloying—results in specific contact resistivities comparable to those of the Au/Ge contacts was developed. Foregoing studies of these contacts by Mössbauer spectroscopy and x-ray diffraction (XRD),10,11 Rutherford backscattering (RBS), and Auger electron spectroscopy (AES),12 are marked by the absence of any evidence in favor of the doping model, whereas strong arguments for both the graded crystalline and amorphous heterojunction model were obtained. However, although Mössbauer spectroscopy has proven to be sensitive in probing the substitution of Te dopants on electrically active sites (substitutional on As site),13 its sensitivity is limited to Te configurations representing more than 1 percent of the total. Therefore the presence of a thin highly doped n⁺ layer could not be ruled out. On the other hand Raman spectroscopy is a very sensitive method in probing the doping of semiconductors. Doping levels > 10¹⁷ cm⁻³ can easily be detected even if the width of the doped layer is very small.

In this letter we report Raman spectroscopical investigations of both furnace and pulsed laser alloyed Au/Te/Au/GaAs contacts. To identify the phases after alloying, Ga₅Te₅ and Te single crystals have been studied as well. Also n⁺ GaAs layers with thicknesses between 17 and 230 nm grown on semi-insulating (SI) and n-doped (n = 3 x 10¹⁷ cm⁻³) substrates are investigated. The results of resistance measurements on the contacts are briefly summarized.

II. EXPERIMENTAL

The metallization was performed by successive deposition of 50 Å Au, 500 Å Te and 1200 Å Au on (100)
oriented GaAs. For the pulsed laser beam mixing a Nd:YAG laser ($\lambda = 532$ nm, $t = 7$ ns) was used. Different contact structures were produced by varying the laser energy fluency and the number of pulses. The GaAs substrate material for Raman investigations was semi-insulating for the laser beam mixed samples and semi-insulating and uniformly (Si) doped ($n = 3 \times 10^{17}$ cm$^{-3}$) for the furnace alloyed samples. The furnace alloying was performed in a graphite strip heater. The samples were heated for 15 s under a forming gas ambient.

The resistance values determined by $I-V$ measurements on samples with uniformly doped substrate material, are shown in Fig. 1 for laser mixed samples with different treatments (see also Ref. 10). Ohmic contacts are those with a resistance $< 25 \Omega$. The laser annealed contacts show a reduction in the resistance by increasing the energy fluency of a single pulse or by increasing the number of pulses. Contact resistances comparable to those of furnace annealed samples ($T_{\text{alloy}} > 500 ^\circ \text{C}$) have been achieved.

Raman measurements were made at room temperature in backscattering configuration, using the 457, 488, and 514 nm lines of an Ar$^+$ ion laser and the 647 nm line of a Kr$^+$ ion laser. The information depth in Raman measurements is given by the light penetration depth which varies between 50 and 200 nm for the different laser lines in GaAs. The scattered light was analyzed by a Dilor XY triple monochromator with multichannel detection which allowed micro and macro Raman experiments. Thereby the spatial resolution was about 2 and 100 $\mu$m, respectively. The power of the incident laser light was kept below 1 mW to protect the samples against heating effects during the Raman measurements. In these contact structures gallium telluride compounds were the materials most sensitive against overheating. Hence a laser power of 10 mW was only used if no gallium telluride features were observable.

To exclude any heating effects macro Raman measurements with a laser power of 0.2 mW were performed.

In Raman spectra information about the structure and the composition of the samples is given by the phonon frequencies, while information about the doping level can be obtained from the frequency of coupled plasmon LO phonon modes. Therefore, Raman measurements give information about the mechanisms responsible for the ohmic character of laser and furnace alloyed contacts. The two different contributions (doping and structure) to the spectra have different symmetry selection rules. The symmetry can be probed by using different orientations for the polarizations of the incident and scattered light. For example, for a backscattering experiment from a (100) surface with the polarization of the incident light along (010) and for the scattered light along (001) direction of the substrate the scattering configuration will in the following be indicated by: $z(xv)z$.

III. RESULTS AND DISCUSSION

First we discuss the furnace annealed ohmic contacts. In Fig. 2 Raman spectra are shown which have been obtained with a power of the incident laser light $< 1$ mW. By probing different positions on the sample surface an inhomogeneity of the sample is found. From some parts of the sample no Raman signals are detected. This can be explained by the presence of metal islands composed of Au and Ga which are indicated by transmission electron microscopy (TEM) and AES results. In between the islands different features in the Raman spectra are observed (Figs. 2(a) and 2(b)). In Fig. 2(a) there are peaks at 140, 118, and 93 cm$^{-1}$ which correspond to the phonon frequencies of Te [Fig. 2(c)]. The larger full width at half maximum (FWHM) of the phonon peaks in Fig. 2(a) is due to a polycrystalline morphology of the Te. Additional peaks at 128 and 145 cm$^{-1}$ are found. By comparing Fig. 2(b) to a spectrum taken from a Ga$_2$Te$_3$ single crystal [Fig. 2(d)] the formation of Ga$_2$Te$_3$ can be assumed. The peak at 119 cm$^{-1}$ in Fig. 2(b) is due to the coexistence of Te at this location. The nature of the peak at 107 cm$^{-1}$ is not yet understood. From macro Raman experiments heating effects during the measurements can be ruled out.

Also signals from the GaAs region below the ohmic contact [Fig. 2(b)] are detected. Apart from the symmetry
allowed LO phonon at 291 cm\(^{-1}\), a peak at 269 cm\(^{-1}\) is observed. There are two possible explanations for the appearance of this peak. First it can be an \(\Omega^-\) mode of coupled plasmon LO phonon modes (PLP) which are observed in doped GaAs\(^{14,15}\). Secondly this peak can be explained by the existence of a high density of defects. This will relax the selection rules yielding \(k\)-induced scattering processes from TO phonons. \(k\)-induced scattering occurs in highly disordered samples like ion implanted\(^{17}\) or ion bombarded\(^{18}\) GaAs samples.

To distinguish between these two possible explanations heavily doped GaAs reference samples are studied, spectra are shown in Fig. 3. In doped GaAs the fluctuations in the free carrier density and the LO phonon interact via their electric fields leading to coupled PLP modes.\(^{14,15}\) The frequencies of these modes (\(\Omega^-\) and \(\Omega^+\) mode) allow the estimation of doping levels in between \(10^{17}\) and \(10^{19}\) cm\(^{-3}\). Depending on their frequencies the character is more phonon or plasmon like, leading to different symmetry selection rules. Especially an \(\Omega^-\) mode close to the TO phonon frequency of GaAs has the same symmetry as the LO phonon and will give only a contribution to the spectra in the allowed scattering configuration \(x(xy)z\) [Fig. 3(a)].

To find out how sensitive Raman spectroscopy is for the proof of the presence of doped layers very thin heavily doped (\(n \approx 8 \times 10^{18}\) cm\(^{-3}\)) molecular beam epitaxy (MBE) grown samples are studied. The spectrum shown in Fig. 3(b) was taken on a sample with a thickness of the doped layer equal 30 nm. However from the fact that the \(\Omega^+\) mode can clearly be observed on samples where the thickness of the doped layer is 1/\(n\) nm, the limit for the width of the doped layer which is detectable should be below 15 nm. Obviously the detection limit must be larger than the sum of the width of the depletion layers at the surface and the interface, because for measuring PLP modes fluctuations in the free carrier density are necessary. Therefore, for higher doping levels the presence of doped layers with thicknesses even smaller than 15 nm can be detected. For these Raman studies the 457-nm laser line has been used, because the light penetration depth must be larger than the width of the surface depletion layer. That is the reason why the intensity and therefore the sensitivity could not be enhanced by using a laser line (413 nm) which is in resonance to one of the energy gaps of GaAs.

Taking these results into account an explanation of the 269 cm\(^{-1}\) peak, which has been observed in the spectra of the ohmic contacts can be given. If this peak is assumed to be an \(\Omega^-\) PLP mode, then an \(\Omega^+\) mode must occur at higher wave numbers. However we do not observe such a peak even if a laser line (\(\lambda_L = 647\) nm) with a larger penetration depth is used. Beside this, the intensity of the 269 cm\(^{-1}\) peak has been the same for both scattering configurations \(x(xy)z\) and \(x(yy)z\) [Fig. 4]. From these facts the explanation by a PLP mode can be excluded and the peak can only be explained by a disorder activated \(k\)-induced TO phonon scattering.

Thus we can conclude, that the ohmic behavior of the furnace annealed contacts is due to a heterojunction between disordered GaAs and Ga\(_2\)Te\(_3\). These results are compatible with former Mössbauer and RBS measurements.\(^{11,12}\) An explanation of the ohmic characteristic based on \(n^+\) doping of the Ga\(_2\)Te\(_3\) layer caused by diffusion of As remains possible, but could not be studied by Raman spectroscopy.\(^{19}\)

In the Raman spectra from the laser annealed contacts different features are observed, depending on the energy fluency and the number of pulses during the annealing process. In Fig. 5, the Raman spectra of a highly resistive contact (0.35 J/cm\(^2\), 5 pulses) which show a lateral inhomogeneity are presented. Beside other peaks a broad structure around 130 cm\(^{-1}\) is observed [Fig. 5(a)].

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**FIG. 3.** Spectra from heavily doped reference samples grown by MBE (\(\lambda_L = 457\) nm). (a): Light scattering from an \(\Omega^-\) mode using different scattering configurations. The thickness of the doped layer is 230 nm and the doping level is \(1.3 \times 10^{19}\) cm\(^{-3}\). (b): Spectrum from a heavily doped GaAs sample with a thickness of the doped layer of 30 nm. The frequency of the \(\Omega^+\) mode corresponds to a doping level of \(8 \times 10^{18}\) cm\(^{-3}\).

**FIG. 4.** The peak at 269 cm\(^{-1}\) in spectra obtained on ohmic contacts is a disorder activated TO phonon (\(\lambda_L = 457\) nm). Its intensity is the same for both scattering configurations (sample: \(n = 3 \times 10^{17}\) cm\(^{-3}\), \(T_{ahpy} = 550^\circ\)C).
FIG. 5. Raman spectra from laser annealed contacts (λL = 514 nm). The nonohmic samples (0.35 J/cm², 5 pulses) show a lateral inhomogeneity (a and b) and on ohmic samples (0.85 J/cm², 5 pulses) amorphous GaAs (c) is found. (a) Gallium telluride features around 130 cm⁻¹, (b) A₁g and E₂ of As, (c) amorphous-like GaAs.

this with literature data scattering from amorphous²⁰ and crystalline Te can be ruled out. However, this structure might arise from gallium telluride phonons. We also observed similar structures on 0.35 J/cm², 1 pulse samples. For this contacts traces of gallium telluride have also been observed by Mössbauer spectroscopy¹⁰ and XRD.²¹ Beside gallium telluride phonons additional phonons are detected at 195 and 253 cm⁻¹ [Fig. 5(b)] by Raman spectroscopy. These are the E₂ and A₁g modes of elemental As.²² This suggests that an exchange reaction between Te and As takes place during the annealing process. A gallium telluride phase is formed an elemental As is set free in islands on top of the sample surface. The effect of elemental As to the Schottky barrier height is not yet clear. It is reported that the barrier height could be decreased by outdiffusion of As causing the formation of As vacancies²³ and increased by the formation of As clusters at the surface.²⁴ Even on the ohmic contacts annealed with an energy fluency of 2.5 J/cm² and 1 pulse elemental As is detected. From the presence of As in the surface layer of ohmic and of rectifying contacts it can be concluded that the transition to ohmic characteristics is not caused by As. An explanation for the rectifying character even in the presence of gallium telluride can be the inhomogeneity of the contact region and the formation of a compound consisting of Ga₂Te₃ because no clear Ga₂Te₃ phonon peaks are observed which could also be caused by a highly disordered Ga₂Te₃ phase. The increasing background towards lower wave numbers in Fig. 5 is caused by a diffuse backscattering of the laser light at the rough surface of the sample.

On the ohmic laser alloyed samples no features from a gallium telluride compound have been found. Again a peak near the GaAs TO phonon frequency is observed. This peak appears in the forbidden and in the allowed scattering configuration. Additionally no Ω⁺ mode is found up to 2000 cm⁻¹ relative to the laser line. Therefore, from Raman measurements a doping of the contact region of 10¹⁷ to 10²⁰ cm⁻³ can be excluded. Again an explanation of the observed peak by an Ω⁻ mode can be excluded and it should be a defect or disorder activated TO phonon. Combining this with Mössbauer results, a doping of the contact region larger than 10¹⁷ cm⁻³ can be ruled out. Also a small LO phonon is observed which is shifted towards 286 cm⁻¹. Such a shift has been reported for ion bombarded GaAs (100) wafers and has been explained by the change in the ionic plasma frequency—changing the TO/LO splitting—due to a high density of defects.²⁵ Preliminary photoluminescence experiments also indicate the formation of a disordered GaAs surface layer.

An additional feature observed by Raman spectroscopy corresponds to amorphous-like GaAs [Fig. 5(c)]. This spectrum represents rather the density of phonon states than a certain phonon peak.

In the Raman spectra an increasing background towards higher wave numbers [Fig. 5(b)] is observed. This belongs to a very broad structure (Fig. 6), which is similar to the one reported previously for furnace alloyed Au/Ge contacts to GaAs.²⁶ There it has been attributed to a Raman signal of an overdoped compensated sample. Based on this observation, conduction in this contact structure was argued to occur by an impurity assisted resonant tunneling process. We found that the broad structure is not a special feature of ohmic samples. It has been observed on non-ohmic samples with even higher intensities. Hence a discussion concerning the ohmic behavior based on this broad structure is not crucial. Additionally the maximum of this peak shifts as a function of the exciting wavelength λL (Fig. 6, inset), but for very different λL also the relative position of the maximum to λL changes. The same feature has been observed on Au/GaAs (100) laser mixed samples. Hence, we conclude that it is a photoluminescence signal which is also strengthened by missing of an anti-
FIG. 6. Raman spectrum ($\lambda = 457$ nm) of the high-energy shifted region on sample (2.5 J/cm², 1 pulse). The maximum of the broad structure shifted as a function of the exciting laser energies (inset).

Stokes signal. The peak maximum seems to depend on the light penetration depth relative to the incorporation length of Au or of elementary point defects of GaAs.

IV. CONCLUSION

Comparing the results of the furnace annealed and the laser mixed contacts a different structural nature of the contacts is found. For furnace annealed contacts the mechanism which is responsible for the ohmic behavior is dominated by the formation of a Ga₅Te₃, polycrystalline Te and a highly disordered GaAs layer. Ga₅Te₃ is indicated by its vibration modes. No evidence for a doping of the GaAs caused by the furnace annealing is found.

Although on the low-energy fluency laser beam mixed samples gallium telluride compounds are formed, these contacts are highly resistive. On the ohmic laser alloyed contacts a disordered interfacial GaAs layer is present. A doping caused by the mixing can be excluded. Hence, we guess that an electron tunneling through the potential barrier involving localized gap states is the main mechanism for the ohmic behavior as it is also proposed in Ref. 10.